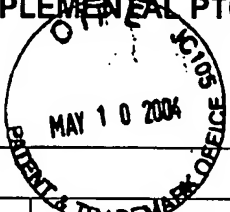


<b>INFORMATION DISCLOSURE CITATION</b>  <b>SUPPLEMENTAL PTO-1449</b>		ATTY. DOCKET NO.		SERIAL NO.		
		07783.0013.NPUS00		10/718,990		
		APPLICANT : Rong-Chang Liang, et al.				
		FILING DATE		GROUP		
		11/21/2003		1712		
<b>U.S. PATENT DOCUMENTS</b>						
EX'R INITIAL	PATENT NO.	DATE MM-YYYY	NAME	CLASS	SUBCLASS	FILING DATE
SH	09/759,212 (WO 02/056097)	11-2001 (07-2002)	Liang, et al	+	+	
PA	US 2002-75556 (09/942,532)	06-2002 (08-2001)	Liang, et al	+	+	
PA	USSN 09/518,488	Filed 03/03/2000	Liang et al	+	+	
PA	USSN 10/444,760	Filed 05/23/2003	Liang et al	+	+	
PA	USSN 10/388,890	Filed 03/14/2003	Liang et al	+	+	
SH	USSN 10/372,027	Filed 02/21/2003	Liang et al	+	+	
PA	USSN 10/351,460	Filed 01/24/2003	Liang et al	+	+	
SH	2002/0196525	12/26/2002	Chen et al.	+	+	
PA	2002/0188053	12/12/2002	Zang et al.	+	+	
SH	2002/0029969	03/14/2002	Yager et al.	+	+	
PA	2002/0018043	02/14/2002	Nakanishi	+	+	
PA	3,229,607	01/18/1966	Battaglia	+	+	
PA	3,612,758	10/12/1971	Evans	+	+	
PA	3,668,106	June 1972	Ota	+	+	
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PA	4,071,430	Jan 1978	Liebert	+	+	
PA	4,093,534	June 1978	Carter et al	+	+	
PA	4,190,352	02/26/1980	Bruning	+	+	

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EX'R INITIAL	PATENT NO.	DATE MM-YYYY	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
PA	CA 2,340,683	Nat'l Entry 2/14/2001	Canada (Schmidt, F. G.)			<input checked="" type="checkbox"/>	<input type="checkbox"/>
PA (ABS)	DE 199 27 359.6	Pub. Date 12/21/00	Germany (Schmidt, F. G.)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
	EP 0 990 942	Pub Date 04/05/2000	Europe (Yamanaka)			<input type="checkbox"/>	<input type="checkbox"/>
PA	EP 1 065 553	Pub Date 01/03/2001	Europe (Ogawa)			<input type="checkbox"/>	<input type="checkbox"/>
PA	EP 1 089 118	Apr 2001	EPO			<input type="checkbox"/>	<input type="checkbox"/>
PA	EP 1 195 603	Pub Date 04/10/2002	Europe (Kawai)			<input type="checkbox"/>	<input type="checkbox"/>
PA (ABS)	JP 6242423	Pub Date 09/02/1994	Japan (Nakai Yuichi) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 64-86116	Pub Date 03/30/1989	Japan (Osamu et al) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 60-205452	Pub Date 10/17/1985	Japan (Hisanori) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 2000 035677	Pub Date 02/02/2000	Japan (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 2000 075497	Pub Date 03/14/2000	Japan (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 2001 042118	Pub Date 02/16/2001	Japan (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 2001 056653	Pub Date 02/27/2001	Japan (Hayakawa) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 02284126	Pub Date 11/21/1990	Japan (Oshiro) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 59171930	Sep 1984	Japan (English abstract included)			<input type="checkbox"/>	<input type="checkbox"/>
PA (ABS)	JP 02284125	Nov 1990	Japan (English abstract included)			<input type="checkbox"/>	<input type="checkbox"/>

PA (ABS)	JP 02223934	Sep 1990	Japan (English abstract included)			<input type="checkbox"/>	<input type="checkbox"/>
PA (ABS)	JP 57104116	Jun 1982	Japan (English abstract included)			<input type="checkbox"/>	<input type="checkbox"/>
PA (ABS)	JP 62-203123	Pub Date Sep 1987	Japan (English abstract included)			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 98/57226	Dec 1998	PCT			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 99/08151	Pub Date 02/18/1999	PCT ( Bruzzone et al.)			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 99/53373	Pub Date 10/21/1999	PCT (Drzaic)			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 99/56171	Nov 1999	PCT			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 00/03291	Pub Date 01/20/2000	PCT (Jacobson et al.)			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 00/36649	Jun 2000	PCT			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 00/60410	Oct 2000	PCT			<input type="checkbox"/>	<input type="checkbox"/>
PA (ABS)	WO 00/77571	Pub Date 12/21/00	PCT <sup>1</sup> (Schmidt, F. G.)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA	WO 01/67170	Pub Date 09/13/2001	PCT (Liang et al.)			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 02/01281	Pub Date 01/03/2002	PCT (Liang et al.)			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 02/56097	Pub Date Jul 2002	PCT (erroneously identified as WO 02/56079 on page 3 of Spec.)			<input type="checkbox"/>	<input type="checkbox"/>
PA	WO 02/65215	Aug 2002	PCT			<input type="checkbox"/>	<input type="checkbox"/>
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814 (ABS)	Chen, S.M., « The New Applications and the Dynamics of Companies », <i>TRI</i> , May, 2003 (in Chinese, English abstract attached, full translation available upon request)
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EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.	
*If an asterisk is placed beside the reference number, a copy is not provided because the reference was previously cited by or submitted to the PTO in a prior application that is identical in the statement and relied upon for an earlier filing date under 35 U.S.C. §120. 37 C.F.R. §1.98 (d).	